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PATENTS

Attorney Docket No.: ELM-1 CONT.15

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Glenn J. Leedy
Application No. : 10/766,629 Confirmation No.: 3771
Filed : January 27, 2004
For : APPARATUS AND METHODS FOR MASKLESS PATTERN
GENERATION
Group Art Unit : 2818
Examiner : Thinh T. Nguyen

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97,
applicant wishes to call the attention of the Examiner to the
following documents:

	<u>U.S. Patents</u>	
Lofgren et al.	6,230,233	05/08/2001
Brandes et al.	6,445,006	09/03/2002
Leedy	6,682,981	01/27/2004
Leedy	6,713,327	03/30/2004

	<u>Foreign Patents</u>	
Suzuno et al.	JP S63-076484	04/06/1988
Kawagishi et al.	EP 0 518 283	12/16/1992
Viefers et al.	WO 03/078305	09/25/2003

Other Documents

Sung, et al., "Well-aligned carbon nitride nanotubes synthesized in anodic alumina by electron cyclotron resonance chemical vapor deposition," Applied Physics Letters, Volume 74, Number 2, 197, 1999, January 11, 1999.

Phys. Rev., B, Condens, Matter Mater. Phys. (USA),
Physical Review B (Condensed Matter and Materials
Physics), 15 March 2003, APS through AIP, USA.

These documents are listed on the accompanying Form PTO-SB/08A (submitted in duplicate), and pursuant to 37 C.F.R.

§ 1.98(a)(2), copies of the non-U.S. Patent documents are enclosed herewith.

Applicant reserves the right to establish the patentability of the claimed invention over any of the information provided herewith, and/or to prove that this information may not be prior art, and/or to prove that this information may not be enabling for the teachings purportedly offered.

One of the references cited in this Supplemental Information Disclosure Statement (i.e., Lofgren et al. U.S. Patent 6,230,233) was cited in a communication from the U.S. patent office in a co-pending, commonly-assigned U.S. application. In particular, this reference was cited in the March 11, 2005 Office Action in U.S. application No. 10/143,200. A copy of that Office Action is not enclosed herewith, as applicant assumes that it is readily available to the Examiner. However, if it is desirable for the Examiner to have the applicant provide the Office Action, applicant will do so on the request of the Examiner.

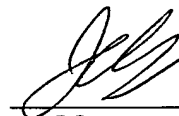
It is respectfully requested that these references be: (1) fully considered by the Patent and Trademark Office

during the examination of this application; and (2) printed on any patent which may issue on this application. Applicant requests that a copy of Form PTO-SB/08A, as considered and initialed by the Examiner, be returned with the next communication.

This Statement is being submitted before the mailing date of the first Office Action on the merits. Pursuant to 37 C.F.R. § 1.97(b)(3), submission of this Supplemental Information Disclosure Statement requires no fee. However, if for any reason a fee is due, the Director is hereby authorized to charge payment of any fees required in connection with this Statement, or credit any overpayment of the same, to Deposit Account No. 06-1075. A duplicate copy of this Supplemental Information Disclosure Statement is enclosed herewith.

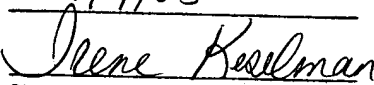
An early and favorable action is respectfully requested.

Respectfully submitted,



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Substitute for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if known	
				Application Number	10/766,629 (Conf. No.: 3771)
				Filing Date	January 27, 2004
				First Named Inventor	Glenn J. Leedy
				Art Unit	2818
				Examiner Name	Thinh T. Nguyen
Sheet	1	of	1	Attorney Docket Number	ELM-1 CONT.15

U.S. PATENT DOCUMENTS					
Examiner initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		6,230,233	05/08/2001	Lofgren et al.	
		6,445,006	09/03/2002	Brandes et al.	
		6,682,981	01/27/2004	Leedy	
		6,713,327	03/30/2004	Leedy	

FOREIGN PATENT DOCUMENTS						
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		Country Code ¹ - Number ² - Kind Code ³				
		JP S63-076484	04/06/1988	Suzuno et al.		
		EP 0 518 283	12/16/1992	Kawagishi et al.		
		WO 03/078305	09/25/2003	Viefers et al.		

NON PATENT LITERATURE DOCUMENTS			
Examiner initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ⁶
		Sung, et al., "Well-aligned carbon nitride nanotubes synthesized in anodic alumina by electron cyclotron resonance chemical vapor deposition," Applied Physics Letters, Volume 74, Number 2, 197, 1999, January 11, 1999.	
		Phys. Rev., B, Condens. Matter Mater. Phys. (USA), Physical Review B (Condensed Matter and Materials Physics), 15 March 2003, APS through AIP, USA.	

Examiner Signature		Date Considered	
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All References Have Been Considered: _____
Examiner

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language translation is attached.